

Receipt

PATENT
Atty. Dkt. No. AMAT/4227.P1/DD/BCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:
Latchford, et al.

Serial No.: 09/921,938

Filed: August 02, 2001

Confirmation No.: 8367

For: Photolithography Scheme
Using A Silicon Containing
Resist

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Group Art Unit: 1756

Examiner: A. Walke

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Assistant Commissioner for
Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING 37 CFR 1.8	
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<u>4/26/02</u> Date	<u>B. Todd Patterson</u> Signature

Dear Sir:

REQUEST FOR CORRECTION OF ERROR ON FILING RECEIPT

The Filing Receipt for the above-referenced application contains an error regarding the attorney docket number. The Filing Receipt recites the attorney docket number as [AMAT/4375/DD/BCVD]. The attorney docket number should read AMAT/4227.P1/DD/BCVD/JW.

Attached is a copy of the Filing Receipt with the above change noted thereon. Please correct this error or notify the applicants of the reasons for denying the request.

Respectfully submitted,

B. Todd Patterson

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/921,938 ✓	08/02/2001 ✓	1756 ✓	1142 ✓	AMAT/4287.71/00/BLVD/JW	12 ✓	44 ✓	3 ✓

Insert → AMAT/4287.71/00/BLVD/JW

CONFIRMATION NO. 8367 ✓

FILING RECEIPT



OC000000006532717

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA 95052 ✓

REC'D SEP 12 2001

Date Mailed: 09/07/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

- ✓ Ian Latchford, Sunnyvale, CA; ✓
- ✓ Christopher Dennis Bencher, San Jose, CA; ✓
- ✓ Yuxiang Wang, Palo Alto, CA; ✓
- ✓ Mario Dave Silvetti, Morgan Hill, CA; ✓

Assignment For Published Patent Application

Applied Materials, Inc.; ✓

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A CIP OF 09/590,322 06/08/2000 ✓ ✓

Foreign Applications

If Required, Foreign Filing License Granted 09/07/2001

Projected Publication Date: 12/20/2001

Non-Publication Request: No

Early Publication Request: No

Title

COMPUTER ENTERED

SEP 12 2001

Photolithography scheme using a silicon containing resist

✓
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Preliminary Class

430

Data entry by : HAILE, MENTUAB

Team : OIPE

Date: 09/07/2001

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